Electronic Pat	en App	incation ree	: 114113111	ıttai			
Application Number:	107	10702049					
Filing Date:	06-	06-Nov-2003					
Title of Invention:		METHOD OF IMPROVING POST-DEVELOP PHOTORESIST PROFILE ON A DEPOSITED DIELECTRIC FILM					
First Named Inventor/Applicant Name:	No	Noriaki Fukiage					
Filer:	Jan	James Klekotka					
Attorney Docket Number:	FIS	FIS920060073US1 (RAJ-014)					
Filed as Large Entity	•						
Utility under 35 USC 111(a) Filing Fees							
Description		Fee Code	Quantity	Amount	Sub-Total ii USD(\$)		
Basic Filing:					ı		
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
				1510	1510		

Publ. Fee- early, voluntary, or normal

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
	Total in USD (\$)			1810